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CONFIRMATION NO. 8727

SERIAL NUMBER 10/524,778	FILING OR 371(c) DATE 02/16/2005 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. ABE-026
APPLICANTS Shigeru Umeno, Tokyo, JAPAN; Masakata Hourai, Tokyo, JAPAN; Masakazu Sano, Tokyo, JAPAN; Shinichiro Miki, Tokyo, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/16441 12/19/2003				
** FOREIGN APPLICATIONS *****				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged _____ Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 1	TOTAL CLAIMS 28
INDEPENDENT CLAIMS 4				
ADDRESS Kubovcik & Kubovcik Farragut Building Suite 710 900 17th Street N W Washington ,DC 20006				
TITLE Manufacturing method of silicon wafer				
FILING FEE RECEIVED 1500	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	